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# (12) United States Patent Ota

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### (54) LASER TREATMENT APPARATUS

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## (57) ABSTRACT

A laser treatment apparatus for irradiating a treatment part with a laser beam for treatment is disclosed. The apparatus includes a treatment light irradiation unit including a treatment light source which emits the treatment laser beam, an irradiation optical system which delivers the treatment laser beam emitted from the light source to irradiate the treatment part, and a laser emission end unit internally provided with a part of the irradiation optical system. The apparatus further includes a movement unit which moves the emission end unit with respect to the treatment part, a determination unit which determines an irradiation position of the treatment laser beam, and a control section which transmits a control signal to the movement unit based on a determination result by the determination unit and controls laser irradiation.

## 6 Claims, 10 Drawing Sheets

